

MEANS FOR DETECTING A LEAK

CROSS-REFERENCE TO RELATED APPLICATIONS

[0001] This application claims the benefit of German Patent Application 103 14 924.4, filed April 1, 2003. The disclosure of the above application is incorporated herein by reference.

FIELD OF THE INVENTION

[0002] The invention relates to means for detecting a leak.

BACKGROUND OF THE INVENTION

[0003] Different seals are known for sealing shaft passages. Radial shaft sealing rings, slide ring seals, and the like are widely used and their use areas are considerable. A common aspect of all seals, however, is that they are subject to wear and once they have lost their sealing function, they must be replaced. In such cases, leaks that develop must be prevented because, in many applications, they can cause major damage. Hence, the need exists for timely detection of an undesirable leak of a liquid or a gas so that the defective seal may be replaced.

[0004] A system for detecting a leak at a seal is known from DE 100 61 111 A1. The leak detection system of DE 100 61 111 A1 includes a depot for storing the leaked material and a sensor based on an optical principle. The sensor transmits a signal when the optical properties of the depot change as a result of the depot being covered by the leaked liquid.

SUMMARY OF THE INVENTION

[0005] The object of the invention is to provide a sealing system wherein the means for detecting a leak are usable at higher temperatures.

[0006] This objective is reached by designing a measuring device as a condenser with a leak-absorbing depot as a dielectric. As a result, the sealing system can be exposed to substantially higher temperatures.

[0007] In one embodiment, the condenser plates can consist of support rings, for example two installed sealing rings. The use of the support rings as condenser plates is space-saving.

[0008] In another embodiment, the condenser plates are formed by electrically conductive covering layers on two circular sides of the depot. A conductive covering layer can be applied to the depot in a simple and inexpensive manner.

[0009] The conductive covering layers can be arranged in segments distributed over the depot and connected to each other conductively or non-conductively. By an appropriate arrangement of several segments, the leak can be located by appropriate measurements.

[0010] Preferably, the depot is an absorbent and/or swellable circular disk. The circular configuration allows optimal utilization of the available space.

[0011] The depot can be made of a porous material. As a result of their large surface, porous materials can absorb the leaked material.

[0012] The depot preferably consists of an absorbent and/or swellable polymer. Polymeric materials are inexpensive.

[0013] The depot can be made of a nonwoven fabric. Nonwoven fabrics are inexpensive and easy to process.

[0014] In one embodiment, a temperature sensor is disposed in the sealing system. By a temperature measurement, the effects of temperature on the dielectric behavior of the leaked material and the depot can be compensated.

[0015] The leak can be detected by measuring the condenser capacity. To this end, the change in dielectric properties of the depot is a measure of the saturation of the depot with the leaked material, and is determined by measuring the condenser capacity.

[0016] The leak can also be detected by "dielectric spectroscopy", whereby the dielectric behavior of the leaked material and the depot is determined via a frequency. Here, the change in dielectric properties of the depot is also a measure of depot saturation with the leaked material, but this method also determines a leak when the dielectric constants of the leaked material and the depot are similar.

[0017] Further areas of applicability of the present invention will become apparent from the detailed description provided hereinafter. It should be understood that the detailed description and specific examples, while indicating the preferred embodiment of the invention, are intended for purposes of illustration only and are not intended to limit the scope of the invention.

BRIEF DESCRIPTION OF THE DRAWINGS

[0018] The present invention will become more fully understood from the detailed description and the accompanying drawings, wherein:

[0019] Fig. 1 shows in longitudinal cross-section a sealing system with two radial shaft sealing rings and one depot according to a principle of the present invention;

[0020] Fig. 2 shows a sealing system with a device for acquiring measured values according to a principle of the present invention;

[0021] Fig. 3 shows another sealing system with a device for acquiring measured values according to a principle of the present invention;

[0022] Fig. 4 shows a sealing system with a depot having an electrically conductive covering layer applied to each side thereof according to a principle of the present invention;

[0023] Fig. 5 shows a sealing system with a depot having an electrically conductive covering layer applied to each side thereof, the depot being centered in the sealing ring according to a principle of the present invention; and

[0024] Fig. 6 shows a sealing system with two radial shaft sealing rings and a depot with an electrically conductive covering layer according to a principle of the present invention.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0025] The following description of the preferred embodiment(s) is merely exemplary in nature and is in no way intended to limit the invention, its application, or uses.

[0026] Figure 1 shows a sealing system wherein a sealing ring 1 is pressed into a sealing ring 2. A depot 3 is disposed radially between the two sealing rings 1

and 2. The depot 3 consists of a disk of nonwoven fabric that touches the shaft 4 to be sealed. The sealing ring 2 that faces the surroundings has two sealing lips 5 and 6 that form an annular space. This space can be filled with a lubricant to prevent premature wear of outer sealing ring 2. The condenser plates are formed by the two support rings 7 and 8. The depot 3 is disposed between these support rings 7 and 8, and forms a dielectric.

[0027] Figure 2 shows a sealing system wherein the sealing ring 2 that is oriented toward the surroundings is slipped onto a side of sealing ring 1 that faces the surroundings. For mounting purposes, the outer, static sealing region 9 is provided with a recess 10 to which the support ring 7 is fastened. Here, too, the condenser plates are formed by the support rings 7 and 8 of the sealing rings 1 and 2. The depot 3 is disposed between the support rings 7 and 8, and constitutes the dielectric. The depot 3 is a circular disk with an inner diameter that is larger than the diameter of the shaft 4. The depot 3, therefore, absorbs only dripping or spun-off leaks. Further, the support rings 7 and 8 are provided with holes 11, 12 and 13 into which is inserted a plug 14. The upper hole 12 of outer seal 2 has a larger diameter to ensure that the support rings 7 and 8 are not short-circuited through the plug 14.

[0028] Figure 3 shows a sealing system essentially as that of Figure 2. The measured values are recorded via pins 16 and 17 which are fastened and sealed in holes 11 and 13. A plug 14 is slipped onto pins 16 and 17, wherein the plug contains a measuring element 15 for temperature determination intended for compensation of the effects of temperature on the results of the measurement.

[0029] Figure 4 shows a sealing system with a sealing ring 1 and a depot 3 that is fastened to a side of the sealing ring 1 that faces the surroundings. On the two circular sides of the depot 3, provided as condenser plates, are covering layers 18 and 19 that are made of an electrically conductive material. To prevent a short circuit in the covering layers 18 and 19, the covering layers are not completely applied to depot 3, but in a region of shaft 4, are provided with a circular recess.

[0030] Figure 5 shows a sealing system similar to the sealing system shown in Figure 4. The depot 3 with covering layers 18 and 19 is centered in a recess 20 of an outer static sealing region 9 of sealing ring 1.

[0031] Figure 6 shows a sealing system with two sealing rings 1 and 2 between which is radially disposed a depot 3 with covering layers 18 and 19. The arrangement of the sealing rings is the same as that shown in Figure 2. The depot 3 has a larger diameter than the shaft 4. The covering layers 18 and 19 are applied to the entire circular surface of the depot 3. In this manner, the depot 3 with covering layers 18 and 19 is a readily-fabricated, die-cut part. Sealing in the direction of the surroundings is provided by two sealing lips 5 and 6, as described in Figure 1.

[0032] The description of the invention is merely exemplary in nature and, thus, variations that do not depart from the gist of the invention are intended to be within the scope of the invention. Such variations are not to be regarded as a departure from the spirit and scope of the invention.